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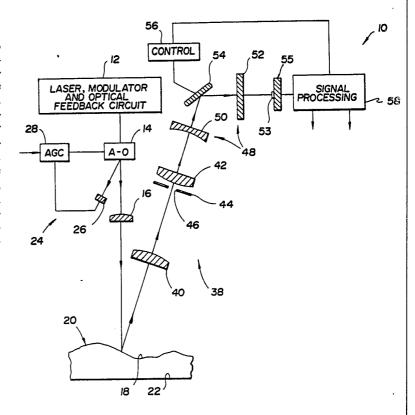
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(54) Title: METHOD AND SYSTEM FOR HIGH-SPEED, HIGH-RESOLUTION, 3-D IMAGING OF AN OBJECT AT A VISION STATION

(57) Abstract

A method and system for high-speed, high-resolution, 3-D imaging of an object at a vision station including an anamorphic magnification and field lens system to deliver the light reflected from the object to a small area position detector having a position-sensing direction. Preferably, an acousto-optic deflector having no moving parts together with associated lens elements scans a beam of modulated laser light in a scanning direction across the object to be inspected to produce a telecentric, flat field scan. The deflector has a feedback loop to enable uniform illumination of the object (i.e. flat field corrrection). The light scattered from the object is collected by a telecentric receiver lens.



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METHOD AND SYSTEM FOR HIGH-SPEED, HIGH-RESOLUTION, 3-D IMAGING OF AN OBJECT AT A VISION STATION

CROSS-REFERENCE TO RELATED APPLICATION

This application is related to U.S. Patent Application entitled "METHOD AND SYSTEM FOR HIGH-SPEED, 3-D IMAGING OF AN OBJECT AT A VISION STATION", U.S.S.N. 052,841 filed May 21, 1987 and having the same Assignee as the present application. The entire disclosure of U.S.S.N. 052,841 is hereby expressly incorporated by reference.

TECHNICAL FIELD

This invention relates to method and system for imaging an object at a vision station to develop dimensional information associated with the object and, in particular, to method and system for the high-speed, high resolution imaging an object at a vision station to develop dimensional information associated with the object by projecting a beam of controlled light at the object.

BACKGROUND ART

A high-speed, high resolution (i.e. approximately .001 inch and finer) 3-D laser scanning system for inspecting miniature objects such as circuit board components, solder, leads and pins, wires, machine tool inserts, etc., can greatly improve the capabilities of machine vision systems. In fact, most problems in vision are 3-D in nature and two-dimensional problems are rarely found.

Several methods have been used to acquire 3-D data: time of flight, phase detection, autofocus, passive stereo, texture gradients, or triangulation.

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The latter approach is well suited for high resolution imaging and is perhaps the most well known technique.

In the general scanning triangulation method a laser beam is scanned across the object to be inspected with a deflector and the diffusely scattered light is collected and imaged onto a position sensitive detector. The scanner can be a rotating polygon, galvanometer, resonant scanner, holographic deflector, or acousto-optic deflector. Likewise, the position sensitive detector can be a linear or area array sensor, a lateral effect photodiode, a bi-cell, or an electro-optic position sensing device. Sometimes, a pair of position detectors are used to reduce shadowing. With linear arrays or area cameras there is severe trade off between shadows, light sensitivity and field of view.

For obtaining very high speed and low light sensitivity, the position sensing system described in the above-noted patent application is preferred. However, if it is not required to detect very low light levels, lateral effect photodiodes can be used at data rates up to about 1 MHz and are inexpensive, commercially available devices.

Often triangulation-based methods and systems have used the concept of "structured light". As described in U.S.P.N. 4,105,925 such a method involves projecting a line or multiple lines onto the surface of the object to be inspected and detecting the displacement of the projected line (or multiple lines) with a video camera. Such systems are now available off-the-shelf and are relatively inexpensive.

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The primary disadvantages of such a system are the very low speeds (typically 10,000 points/-second) and, in the case of multiple projected lines in a single image, ambiguous interpretations of the data result from overlap of adjacent stripes and multiple scattered light between stripes. Both disadvantages can be overcome by replacing (1) the line projector with a flying spot scanner and (2) the video camera with one of several types of position sensitive detectors, as illustrated in U.S.P.N. 4,375,921.

Conventional triangulation based scanners or structured light systems often utilize conventional imaging lenses (i.e., reduction lenses, 35 mm lenses, or cylinder lenses designed for long line detectors) to deliver light to large area position sensitive detectors such as area sensor, linear arrays or large area position sensitive detectors. The large area detectors have several limitations: low speed due to large detector capacitance, high dark currents, and a much higher noise floor than what is found with small area devices.

For example, a 20 mm x 20 mm P-I-N lateral photodiode (equivalent to the approximate area of a typical 1" video camera tube) has a capacitance of several hundred picofarads and a dark current of several microamps. On the other hand, a 2 mm x 2 mm device will have capacitance of about 5 pf and a dark current of about 50 nanoamps. Both the speed and noise performance of the smaller detectors can be orders of magnitude better than the performance achievable with large area devices. The improvement in speed is directly proportional to the reduction in capacitance and the improvement in signal-to-

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noise is at least as large as the square root of the reduction in capacitance.

With typical triangulation-based images it is difficult to deliver light to a small area device without decreasing the field of view (and consequently the inspection speed). Furthermore, if the field of view is increased the height resolution is necessarily decreased in conventional triangulation based imagers. Also, if a spherical reduction lens is used to deliver light to the detector (with the necessary proportional decrease in resolution) the light gathering capability of the system is reduced in proportion to the area. These are severe limitations and impose undesirable trade-offs which limit the system performance.

A "synchronized scanning" approach can be used to overcome this problem as described in U.S. Patent No. 4,553,844 to Nakagawa et al. scanning approach is commonly implemented polygonal or galvanometer driven mirrors. this approach requires that the sensor head contain moving parts in the form of a rotating mirror (for example, in the Fourier plane or telecentric stop position) or a pair of mirrors. In effect, a second mirror is used to follow the spot which is scanning by means of the first mirror. These high speed moving parts are often not desirable, particularly if the sensor is to be subjected to the type of acceleration found with x-y tables and robotic arms in industrial environments.

A dilemma exists with conventional triangulation imagers: it is desirable to use a small detector but unless moving parts are included the field of view becomes too small, the resolution too

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coarse, and the light gathering capability poor. Even if the coarse resolution is tolerable, the loss of light gathering capability also further reduces the system signal-to-noise ratio. The signal-to-noise ratio is not good in the first place (particularly at high speeds) because of the use of the large area detector thereby compounding the problem.

Many other prior U.S. patent describe various methods for the acquisition of 3-D data by means of triangulation. For example, the U.S. patent to Chasson 4,188,544 describes a structured method in which a beam expander and cylinder lens is used to project a line of light onto an object. line of light is sensed with an imaging lens and video camera. The position of each point determined with a peak detection algorithm. The measurement rate is slow due to the readout of the video camera. Multiple lines of light alleviate this problem to some extent.

In the U.S. patent to Bodlaj, 4,201,475, an object is scanned in a position sensing dimension and the time displacement is detected by a single photodetector having a very narrow field of view. The speed of the system is limited by the retrace time of the scanning device at each measurement point. This method is relatively slow especially for the requirements of small part inspection at quasi-video rates (i.e. MHz).

In the U.S. patent to Penny, 4,645,917, a swept aperture profiler is described. It too measures a time displacement for determining position. A galvanometer driven mirror is used to scan a line of data (i.e. x,y coordinates). An acousto-optic deflector is used to scan the position

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sensing dimension and the instant at which the light is received by the photodetection device indicates depth. The use of the A-O deflector for the z dimension scanning represents an improvement over the previous technology. Also, the use of a photomultiplier as a detection device allows for a much improved dynamic range.

The U.S. patent to Balusubramanian, 4,355,-904, describes a triangulation-based method which incorporates a position sensing device in the form of a variable density filter together with a system for sweeping the laser beam and controlling the position of the measurement probe. The tolerance on the density of typical variable filters, whether fabricated with a metallic coating on glass or with photographic film plate, is typically ±5% at any single point.

The U.S. patent to Satoshi Ido, et al., 4,589,773 describes a position sensing method and system for inspection of wafers which utilizes a commercially available position detector. A reduction lens is used to focus the light into a small spot on the surface of the object with a 10X A magnification lens is used in the reduction. receiver (10X) to deliver light to a detector. triangulation angle is 45 degrees with the receiver and detector at complementary angles (90 degrees). This is fine for wafer inspection. However, the method is deficient for several other types inspection tasks because (1) unacceptable shadows and occlusion effects would occur for tall objects; (2) the field of view of the probe is very small; (3) a reduction of the angle to 15 degrees (to reduce shadows) would degrade the height sensitivity significantly; and (4) the detector area is relatively large which limits speed and the signal to noise ratio as the speed of the system is increased.

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The U.S. patent to Nakagawa et al., 4,472,-056, describes a method which involves projection of a line of light and the use of a rectangular CCD as the position sensor. This represents a significant improvement in speed over the method described in the above noted U.S. patent to Chasson and is good for inspection of parts with a relatively limited height range (i.e. 16 levels). Logic and hardware is included for peak detection which can be related to the depth of the object.

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In the U.S. patent to Crabb et al., 4,650,333 a method of structured light projection is described is somewhat complementary to the described in the Nakagawa patent noted immediately A stripe of light produced with a cylindrical lens is swept across the object with an acoustooptic deflector in such a way that a single CCD line array can be used. This is a less expensive way of implementing the structured light method which does not require a custom CCD. Again, the speed and stray light rejection capabilities of the probe are limited which restrict it to depth measurement of objects (like traces) which are not very tall. Nevertheless, the method is suited to the inspection task of trace height measurement.

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The U.S. patent to Haugen, 4,593,967, assigned to Honeywell describes a triangulation-based scanning system utilizing a holographic deflection device to reduce the size and weight of the scanning system and a digital mask for detection

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of position. The digital mask is in the form of binary grey code and requires a detector for each bit (i.e. 8 detectors for an 8 bit code). A single cylinder lens is used in the receiver to convert a spot of light into a thin line which must be sharply focused onto a series of photodetectors. In other words, the spot is converted into a line to deliver the light to the series of long thin detectors. Spatial averaging is not performed in the system nor is the centroid of the light spot determined.

U.S. Patent No. 4,634,879 discloses the use of optical triangulation for determining the profile of a surface utilizing a prism and two photomultiplier tubes in a flying spot camera system. These are arranged in a "bi-cell" configuration. The bicell, however, does not compute the centroid of the received light spot and is therefore sensitive to the distribution of intensity within the received light spot. As an anti-noise feature, amplitude modulation is impressed upon the laser beam and a filter network is used to filter photomultiplier response so as to exclude response to background optical noise.

DISCLOSURE_OF THE INVENTION

An object of the present invention is to provide an improved method and system for high speed, high resolution 3-D imaging of an object at a vision station wherein high speed and sensitivity can be obtained by using a flying spot laser scanner with a light deflector and an optical system to deliver the light reflected from an object to a single, small area position detector such as a lateral effect photodiode to develop dimensional

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information associated with the object while substantially reducing ambient and multiple reflected light.

Another object of the present invention is to provide a triangulation-based method and system for imaging an object at a vision station which overcomes many of the limitations of the prior art methods and systems by achieving excellent height resolution at a narrow triangulation angle wherein shadow and occlusion effects are reduced while having a relatively large field of view.

Yet still another object of the present invention is to provide a method and system for high speed imaging of an object at a vision station to develop high resolution, dimensional information associated with the object and having a high signal-to-noise ratio in a relatively inexpensive and compact fashion and which system can be interfaced with standard, high speed apparatus.

In carrying out the above objects and other objects of the present invention, a method is provided for the high-speed, high resolution 3-D imaging of an object at a vision station to develop dimensional information associated with the object. The method includes the steps of scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined angle to generate a corresponding reflected light signal, receiving the reflected light signal at a second angle with a set of optical components, including first and second lenses and filtering the received signal with the set of optical components. The method further includes the steps of measuring the amount of radiant energy in the reflected light

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signal with a small area position detector having a position-sensing direction, producing at least one electrical signal proportional to the measurement, and computing a centroid value for the reflected light signal from the at least one electrical The method is characterized by the steps of delivering the filtered light signal to the small area position detector with an anamorphic magnificaand field lens system. The lens system includes a third lens for magnifying in position-sensing direction of the position detector and a high speed fourth lens having a relatively short focal length for delivering the light signal to the position detector.

Further in carrying out the above objects and other objects of the present invention, an imaging system for the high-speed, high resolution 3-D imaging of an object at a vision station to develop dimensional information associated with the object The system includes a source for is provided. scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined angle to generate a corresponding reflected light signal and a set of components including first and second lenses for receiving the reflected light signal at a second angle and for filtering the reflected light signal. system further includes measuring means including a small area position detector having a position sensing direction for measuring the amount of radiant energy in the reflected light signal and producing at least one electrical signal proportional to the measurement. Signal processing means computes a centroid value for the reflected light

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signal from the at least one electrical signal. An anamorphic magnification and field lens system includes a third lens for magnifying in the position-sensing dimension of the position detector and a high speed fourth lens having a relatively short focal length for delivering the light signal to the position detector.

Preferably, the fourth lens is specially made to have a speed of f/.5 to f/.7 and a focal length in the range of 20 to 30 mm.

In one construction of the imaging system, the source preferably includes a solid state (i.e. acousto-optic) laser light deflector and the set of optical components preferably includes a mask to control the polarization and acceptance angles of the collected light.

Also, preferably, the measuring means includes a highly sensitive photodetector such as a lateral effect photodiode for converting the radiant energy into at least one electrical current.

Still, preferably, the field of view of the filtered light signal is translated across the position detector by translation means to expand the range of dimensional information associated with the object.

The advantages accruing to the method and system as described above are numerous. For example, such an imaging system can be incorporated into an inspection/gauging product wherein both range and intensity data are acquired.

Also, such a method and system provide high resolution, quasi-video rate, full 3-D imaging at a relatively low cost. A long scan line (i.e. field of view) is achieved as well as a high signal-to-

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noise ratio, height sensitivity and light gathering capability and low capacitance and "dark current".

The present invention overcomes many of the problems of the prior art by utilizing an anamorphic magnification and field lens system to deliver light to a small area position sensor in conjunction with the benefits of utilizing an all solid state light deflection system (i.e. compact, rugged, easy to interface with, etc.)

The objects, features and advantages of the present invention are readily apparent from the following detailed description of the best mode for carrying out the invention when taken in connection with the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

FIGURE 1 is a schematic view illustrating the 3-D method and system of the present invention;

FIGURE 2a is a profile of an object at a vision station having a step profile wherein several positions of the object are labelled;

FIGURE 2b is an illustration of the positions of Figure 2a on a large area detector as a laser spot is scanned from corresponding positions along the object; and

FIGURE 2c is an illustration similar to the illustration of Figure 2b except the method and system of the present invention are utilized to effect the delivery of the reflected light and spot shape to a small area photodetector.

30 BEST MODE FOR CARRYING OUT THE INVENTION

Referring now to FIGURE 1, there are illustrated the major components of a 3-D imaging

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system constructed in accordance with the present invention and generally indicated at 10. The system 10 is positioned at a vision station and includes a controlled source of light such as modulator and optical feedback circuit 12. scanner in the form of an acousto-optic deflector 14 and beam shaping and focusing optics in the form of various lens elements 16 produce a telecentric, flat field scan by projecting a series of laser beams at the reflective surface 18 of an object, generally The object is supported on a indicated at 20. reference, planar surface 22 at the vision station.

Within the block 12 a laser is coupled to a modulator to shift the information to a higher frequency where system noise characteristics are better. The modulator may perform one of many types of modulation, including sine wave, pulse amplitude, pulse position, etc. Preferably, the laser is a solid state laser diode and is "shuttered" with a TTL signal (i.e. TTL modulation). this way, the laser signal is encoded so as to allow separate signal processing functions to be performed during "on" and "off" intervals as described in detail in the above-noted application. Typically, power levels are 20-30 mW (Class III-B) which are well suited for machine vision applications.

A solid state acousto-optic (i.e. A-O) deflector 14, such as one commercially available from Newport Electro-Optics, is preferably used. The deflector is easy to interface with, is very rugged and compact. This presents numerous advantages. The size of the system 10 can be about the size of a video camera. No moving parts are present in the system 10. Long term stability is

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easy to maintain. The system 10 can be made rugged enough to mount on a translator like an x-y table or robotic arm with relatively little effort. Therefore, producing the unit in large quantities is relatively easy. Most A-O deflectors produce about 500 spots/scan line which provides a very convenient interface to digitizers and image processing equipment. The duty cycle is also very high compared to other types of scanners (95% vs. 50%).

The A-O deflector 14 has the advantage of being all solid state as previously discussed. However, due to the nature of diffractive scanning, a smooth illumination gradient of about 10-30% of the average value in the field of view results. Although this type of gradient can sometimes be tolerated, it is undesirable because it offsets a potentially large advantage of laser scanning in general: the ability to deliver the same quantity of light at the same angle of incidence to every point in the field of view.

An optical and electronic feedback loop generally indicated at 24, is utilized to correct this slowly varying gradient (i.e. for flat field correction). The A-O deflector 14 produces both a scanning beam and a "DC" beam which is normally blocked with a spatial filter. This DC beam will contain about 30% of the laser power. By sensing the variations in this beam it is possible to infer the variations in the illumination because the total light is the sum of the scanning (i.e. lst order) light and the DC beam (0th order).

The DC beam is sensed by a photodetector 26 of the loop 24. The resulting electrical signal is used by an automatic gain control circuit 28 (i.e.

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including an amplifier and an integrator) of the loop 24 to attenuate or amplify the RF power applied to the A-O deflector 14 at a balanced mixer. The resulting intensity distribution is flat to about 1% which provides a significant advantage for greyscale inspection and a modest dynamic range improvement for 3-D inspection.

There is generally indicated at 38 an optical system for use in optically processing the light signal reflected from the object 20. The optical system 38 includes a set of optical components, including a telecentric receiver lens 40 to collect scattered light from the object 20 at a position approximately one focal length from the object 20. A reduction focusing lens 42 operates as a telescope objective. The lenses 40 and 42 operates as a preferred conjugate. The reduction lens 42 can be interchanged to accommodate various reduction and magnification ratios. The reduction lens 42 placed directly behind a mask 44.

The mask 44 is located at one focal length from the receiver lens 40 and functions as a telecentric stop to provide a spatial and polarization filtering plane. In one embodiment, the mask forms a rectangular aperture (i.e. spatial filter) positioned at the intermediate spatial filtering plane to reject light received from unwanted angles (i.e. off-axis or stray light) which often arises from secondary reflections from objects outside of the desired instantaneous field of view of the system 10. The mask 44 may be a fixed aperture 46 or electromechanical shutter, or, preferably, is a liquid crystal, binary, spatial light modulator or valve which is dynamically reconfigured under

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software control. Such a configuration is useful for inspection of very shiny objects (reflowed solder, wire bond, loops, pin grids, etc.) which are in close proximity from which multiple reflections will be created. Consequently, both the acceptance angle (through stop size) and polarization of the input light can be digitally controlled prior to delivery to a detector.

If desired, the spatial filter or strip can be programmed in a chosen pattern of opaque and transmissive patterns correlated and matched to the height profile of the object to be detected. For example, a height measurement of shiny pins placed on a shiny background will be more reliable if only a narrow strip corresponding to the height range over which properly positioned pins is viewed. Otherwise, multiple reflections may produce a signal return which is significantly larger than the return produced by useful light. If properly placed, the position of the pin will be reported. If defective, no pin will be found.

When a conventional triangulation-based scanner is used (i.e. a solid state device having no moving parts but an area detector) the aperture 46 of the mask 44 is no larger than necessary for detection of a specified height range, but is still preferably programmable.

The optical system 38 further includes an anamorphic magnification and field lens system, generally indicated at 48. The lens systems 48 includes a pair of anamorphic elements or lenses 50 and 52. The lens 50 is a very long focal length, precision negative cylinder lens to magnify the image in the position-sensing direction. The focal

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length of the lens 50 is typically between about- 300 mm and -1000 mm.

The lens 52 is a custom short focal length cylinder lens having a preferred speed of about f/.5 or f/.6 which is used to expand the field of view and light gathering capability of the system 38. The lens 52 has a focal length of about 25 mm.

FIGURE 2a illustrates the profile of a "step object" wherein several positions on the stop object are labelled.

FIGURE 2b illustrates the labelled positions of Figure 2a as seen in a large area detector as a laser spot is scanned along the object. This represents the prior art.

FIGURE 2c shows the same labelled positions of Figure 2a, and also shows the effect of using the pair of lenses 50 and 52. The lenses 50 and 52, convert a small focused spot of light into a smooth, enlarged rectangular or elliptical spot which uniformly illuminates an extended region of a single position sensitive detector 53 and averages spatial noise resulting from variations in sensitivity from point to point.

The combination of the lenses 42 and 50 serve to provide magnification in the position sensing dimension. The magnification in the position sensing direction is usually greater than 1:1, thereby yielding microscopic magnification.

The lens 52 serves as an anamorphic field lens into which the scan line is imaged. The length of the imaged scan line can be almost as large as the lens 52 (i.e. 40 mm) but is clearly much larger than the dimension of the detector 53. Hence, it serves as the reduction optic. The lens 52 can be

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fabricated in the form of a double convex singlet, a plano convex "hemi-cylinder" or with a gradient index optic having a radial gradient or a combination thereof. A double convex design, however, is preferable.

In order to extend the depth measurement range of the system 10, a tracking mirror 54 is included and can be placed at any of several convenient positions provided it is behind the mask 44 to maintain telecentricity. Alternatively, a small angle deflector can be used but will deviate rather than translate the light beam.

The translating mirror 54 is mounted on a precision miniature stage which is displaced under software control via a control or controller 56 which, in turn, is coupled to a signal processing circuit 58.

The mirror 54 is useful because significantly extend the measurement range of the system 10. For example, the position sensor or detector at any instant can discriminate about 256 levels or height. Several inspection tasks demand an extension of this height range. example, it may be desirable to measure the height of solder on pads which requires depth sensitivity of about .0004 inch. On the other hand, it may be desirable also to measure the position and geometry of component leads which are to be aligned with the The leads may extend upward about .25" or more to the body of the component. This exceeds the linear measurement range of lateral photodiodes. Also, wire loops are very thin and require high spatial and depth resolution for an measurement. However, these wires may also extend

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up to .25" and a sensor which is to accommodate this entire range at the required .0002 inch height and spatial resolution is not practical.

The translating mirror 54 alleviates this The only requirement is that the lens 40 receive the light. The lens 40 can be expected to provide an image size (in the position sensing dimension) which is somewhat larger than detector 53. Displacing the mirror 54 has the effect of translating the total field of view (constrained by the lens 40) across the detector 53 so that many more levels of height can be sensed while still utilizing the small area detector 53.

Preferably, a single detector element utilized as a small area position sensitive detector 43 of the system 10. The system 10 can obtain quite accurate z (i.e. height) measurements with a lateral effect photodiode (LEP), the internal resistance of which provides the depth sensing and computation capability through attenuation of signal currents. The position detector 53 can be lateral effect photodiode like the Si-Tek 2L2 or 2L4 but is preferably a special rectangular lateral effect detector having an approximate 6 mm width and mm dimension along the position These position sensitive devices have direction. substantial speed and depth range advantages over Bi-cells or digital masks (i.e. linear arrays. optical encoder) are not preferred.

The detector 53 is coupled to a pre-amplifier 58 which, in turn, is coupled to the signal processing circuit 58 which computes the centroid of the light spot thereby allowing for non-uniform and directional intensity distributions.

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The signal processing circuit or unit 58 expands/compresses the variable data in order to obtain the proper Z value, grey scale information and special values indicating incorrect height information. The signal processing circuit 58 is described in greater detail in the above-noted application.

Although the system 10 is designed to support a scanning mechanism with no moving parts, it can also be used in the synchronized scanning geometry approach to provide additional benefits, namely increasing resolution using a very small point detector and spatial averaging over the detector.

The above-described imaging method and system present numerous advantages. For example, imaging can be performed at high resolution and at quasi-video rates to obtain full 3-D information. A large scan line (i.e. field of view) is achieved as well as a high signal-to-noise ratio, height sensitivity and light gathering capability and low capacitance and "dark current". Also, such a method and system offer the potential of accurate, quasi-video frame rate depth sensing at low cost.

While the best mode for carrying out the invention has herein been described in detail, those familiar with the art to which this invention relates will recognize various alternative designs and embodiments for carrying out the invention as defined by the following claims.

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What is claimed is:

A method for the high-speed, highresolution, 3-D imaging of an object at a vision station to develop dimensional information sociated with the object, the method including the steps of: scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined angle to generate a corresponding reflected light signal; receiving said reflected light signal at a second angle with a set of optical components including first and second lenses; filtering the received light signal with the set of optical components; measuring the amount of radiant energy in the reflected light signal with a small area position detector having a position-sensing direction and producing at least one electrical signal proportional to the measurement; computing a centroid value for the reflected light signal from the at least one electrical signal; wherein the improvement comprises:

delivering the filtered light signal to the small area position detector with an anamorphic magnification and field lens system, including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for delivering the light signal to the position detector.

2. A method for the high-speed, high-resolution, 3-D imaging of a relatively small object at a vision station to develop dimensional information associated with the object, the method including the steps of: scanning a beam of controlled modulated light in a scanning direction at the surface of the object at a first predeter-

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mined angle to generate a corresponding reflected light signal; receiving said reflected light signal at a second angle with a set of optical components, including first and second lenses; filtering the received light signal with the set of optical components; measuring the amount of radiant energy in the reflected light signal with a small area position detector and producing at least one electrical signal proportional to the measurement; demodulating the at least one electrical signal; and computing a centroid value for the reflected light signal from the at least one demodulated signal; wherein the improvement comprises:

delivering the filtered light signal to the position detector with an anamorphic magnification and field lens system, including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for delivering the light signal to the position detector.

3. An imaging system for the high-speed, high-resolution 3-D imaging of an object at a vision station to develop dimensional information associated with the object, the system including: a source for scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined angle to generate a corresponding reflected light signal; a first set of optical components, including first and second lenses for receiving the reflected light signal at a second angle and for filtering the received light signal; measuring means, including a small area position detector having a position sensing direction for measuring the amount of radiant energy in the

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reflected light signal and producing at least one electrical signal proportional to the measurement; and signal processing means for computing a centroid value for the reflected light signal from the at least one electrical signal, wherein the improvement comprises:

an anamorphic magnification and field lens system including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for delivering the light signal to the position detector.

- 4. The invention as claimed in claim 1 or claim 3 wherein the fourth lens has a focal length in the range of 20 to 30 mm.
- 5. The invention as claimed in claim 4 wherein the fourth lens has a speed in the range of f/.5 to f/.7.
- 6. The invention as claimed in claim 4 wherein the third lens is a negative cylinder lens having a focal length in the range of -300 to -1,000 mm.
- 7. The invention as claimed in claim 5 wherein the fourth lens is a double convex field lens.
- 8. The invention as claimed in claim 3 wherein the second and third lens cooperate to magnify the filtered light signal in the position-sensing direction of the position detector.
- 9. The invention as claimed in claim 1 or claim 3 wherein the set of optical components includes a programmable mask correlated to a height profile of the object for filtering the received light signal.

PCT/US88/04035

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- 10. The invention as claimed in claim 1 or claim 3 wherein the set of optical components includes a mask having a fixed aperture for filtering the received light signal.
- 11. The invention as claimed in claim 9 wherein the first lens has a first focal length and wherein the first lens is adapted to be located a distance approximately equal to the first focal length from the object.
- 12. The invention as claimed in claim 11 wherein the mask is located a distance from the first lens approximately equal to the first focal length.
 - 13. The invention as claimed in claim 1 or claim 3 wherein a single photodetector is utilized to measure the amount of radiant energy in the reflected light signal to thereby convert the radiant energy into an electrical current.
 - 14. The invention as claimed in claim 13 wherein the photodetector is a semiconductor device having a detector area of less than 40 mm^2 .
 - 15. The invention as claimed in claim 13 wherein the photodetector has a detector area of less than 20 $\,\mathrm{mm}^2$.
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 16. The invention as claimed in claim 1 or claim 2 or claim 3 wherein the beam of controlled light is a laser scanning beam.
 - 17. The invention as claimed in claim 16 wherein the laser scanning beam is provided by an acousto-optic deflector.
 - 18. The invention as claimed in claim 17 wherein the light deflector further provides a D.C. beam, the amount of radiant energy in the D.C. beam being measured to produce a control signal propor-

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tional to the measurement, the control signal being utilized to control the light deflector so that the light deflector illuminates the object in a substantially uniform fashion.

19. The invention as claimed in claim 1 or claim 2 or claim 3 wherein the field of view of the filtered light signal is translated across the position detector by translation means to expand the range of dimensional information associated with the object.

20. The invention as claimed in claim 19 wherein the translation means includes a tracking mirror for reflecting the filtered light signal and a controller for controlling movement of the tracking mirror.

21. An imaging system for the high-speed, high-resolution 3-D imaging of a small object at a vision station to develop dimensional information associated with the object, the system comprising: a flying spot laser scanner including deflector for scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined triangulation angle of less degrees to generate a corresponding 20 reflected light signal; a first set of optical components, including first and second lenses for receiving the reflected light signal at a second angle and for filtering the received light signal; measuring means, including a single, small area position detector for measuring the amount radiant energy in the reflected light signal and producing at least one electrical signal proportional to the measurement; signal processing means for computing a centroid value for the reflected light

signal from the at least one electrical signal; and an anamorphic magnification and field lens system including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for delivering the light signal to the position detector.

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ASMENDED CLAIMS

[received by the International Bureau on 5 May 1989 (05.05.89) original claims 1-3, 13 and 21 amended; other claims unchanged (6 pages)]

What is claimed is:

A method for the high-speed, highresolution, 3-D imaging of an object at a vision station to develop dimensional information associated with the object, the method including the steps of: scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined angle to generate a corresponding reflected light signal; receiving said reflected light signal at a second angle with a set of optical including first and second lenses; components filtering the received light signal with the set of optical components; measuring the amount of radiant energy in the reflected light signal with a small area position detector having a detector area and having a position-sensing direction substantially orthogonal to the scanning direction and producing at least one electrical signal proportional to the measurement; and computing a centroid value for the reflected light signal from the at least one electrical signal; wherein the improvement comprises:

delivering the filtered light signal to the small area position detector with an anamorphic magnification and field lens system, including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for reducing in the scanning direction to uniformly illuminate an extended region of the detector area wherein spatial noise resulting from variations in sensitivity from point to point in the detector area are averaged.

2. A method for the high-speed, high-resolution, 3-D imaging of a relatively small object at a vision station to develop dimensional information

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associated with the object, the method including the steps of: scanning a beam of controlled modulated light in a scanning direction at the surface of the object at a first predetermined angle to generate a corresponding reflected light signal; receiving said reflected light signal at a second angle with a set of optical components, including first and second lenses; filtering the received light signal with the set of optical components; measuring the amount of radiant energy in the reflected light signal with a small area position detector having a detector area and having a position-sensing direction substantially orthogonal to the scanning direction and producing at least one electrical signal proportional to the measurement; demodulating the at least one electrical signal; and computing a centroid value for reflected light signal from the at least demodulated signal; wherein the improvement comprises:

delivering the filtered light signal to the position detector with an anamorphic magnification and field lens system, including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for reducing in the scanning direction to uniformly illuminate an extended region of the detector area wherein spatial noise resulting from variations in sensitivity from point to point in the detector area are averaged.

3. An imaging system for the high-speed, high-resolution 3-D imaging of an object at a vision station to develop dimensional information associated with the object, the system including: a source for scanning a beam of controlled light in a scanning direction at the surface of the object at a first

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predetermined angle to generate a corresponding reflected light signal; a first set of optical components, including first and second lenses for receiving the reflected light signal at a second angle and for filtering the received light signal; measuring means, including a small area position detector having detector area and having a position-sensing direction substantially orthogonal to the scanning direction for measuring the amount of radiant energy in the reflected light signal and producing at least one electrical signal proportional to the measurement; and signal processing means for computing a centroid value for the reflected light signal from the at least electrical signal, wherein the improvement comprises:

an anamorphic magnification and field lens system including a third lens for magnifying in the position-sensing direction of the position detector and a fourth lens having a relatively short focal length for reducing in the scanning direction to uniformly illuminate an extended region of the detector area wherein spatial noise resulting from variations in sensitivity from point to point in the detector area are averaged.

- 4. The invention as claimed in claim 1 or claim 3 wherein the fourth lens has a focal length in the range of 20 to 30 mm.
- 5. The invention as claimed in claim 4 wherein the fourth lens has a speed in the range of f/.5 to f/.7.
- 6. The invention as claimed in claim 4 wherein the third lens is a negative cylinder lens having a focal length in the range of -300 to -1,000 mm.
 - 7. The invention as claimed in claim 5 wherein

PCT/US88/04035

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the fourth lens is a double convex field lens.

- 8. The invention as claimed in claim 3 wherein the second and third lens cooperate to magnify the filtered light signal in the position-sensing direction of the position detector.
- 9. The invention as claimed in claim 1 or claim 3 wherein the set of optical components includes a programmable mask correlated to a height profile of the object for filtering the received light signal.
- 10. The invention as claimed in claim 1 or claim 3 wherein the set of optical components includes a mask having a fixed aperture for filtering the received light signal.
- 11. The invention as claimed in claim 9 wherein the first lens has a first focal length and wherein the first lens is adapted to be located a distance approximately equal to the first focal length from the object.
- 12. The invention as claimed in claim 11 wherein the mask is located a distance from the first lens approximately equal to the first focal length.
- 13. The invention as claimed in claim 3 wherein the position detector includes a single photodetector to measure the amount of radiant energy in the reflected light signal to thereby convert the radiant energy into an electrical current.
- 14. The invention as claimed in claim 13 wherein the photodetector is a semiconductor device having a detector area of less than 40 mm^2 .
- 15. The invention as claimed in claim 13 wherein the photodetector has a detector area of less than 20 $\mbox{mm}^2.$
 - 16. The invention as claimed in claim 1 or

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claim 2 or claim 3 wherein the beam of controlled light is a laser scanning beam.

- 17. The invention as claimed in claim 16 wherein the laser scanning beam is provided by an acousto-optic deflector.
- 18. The invention as claimed in claim 17 wherein the light deflector further provides a D.C. beam, the amount of radiant energy in the D.C. beam being measured to produce a control signal proportional to the measurement, the control signal being utilized to control the light deflector so that the light deflector illuminates the object in a substantially uniform fashion.
- 19. The invention as claimed in claim 1 or claim 2 or claim 3 wherein the field of view of the filtered light signal is translated across the position detector by translation means to expand the range of dimensional information associated with the object.
- 20. The invention as claimed in claim 19 wherein the translation means includes a tracking mirror for reflecting the filtered light signal and a controller for controlling movement of the tracking mirror.
- 21. An imaging system for the high-speed, high-resolution 3-D imaging of a small object at a vision station to develop dimensional information associated with the object, the system comprising: a flying spot laser scanner including a light deflector for scanning a beam of controlled light in a scanning direction at the surface of the object at a first predetermined triangulation angle of less than 20 degrees to generate a corresponding reflect light signal; a first set of optical components, including

first and second lenses for receiving the reflected light signal at a second angle and for filtering the received light signal; measuring means, including a single, small area position detector having a detector having position-sensing direction a substantially orthogonal to the sensing direction for measuring the amount of radiant energy reflected light signal and producing at least one electrical signal proportional to the measurement; signal processing means for computing a centroid value for the reflected light signal from the at least one electrical signal; and an anamorphic magnification and field lens system including a third magnifying in the position-sensing direction of the position detector and a fourth lens relatively short focal length for reducing in the scanning direction to uniformly illuminate an extended region of the detector area wherein spatial noise resulting from variations in sensitivity from point to point in the detector area are averaged.

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STATEMENT UNDER ARTICLE 19

This response to the International Search Report of the present international application under the Patent Cooperation Treaty has revised independent claims 1, 2, 3 and 21 and dependent claim 13 in accordance with revisions previously made to the corresponding United States patent application Ser. No. 150,135 filed January 29, 1988. More specifically, all of the independent claims from which all of the dependent claims depend and the one dependent claim, have been revised to more specifically define an invention that is not taught or suggested by the references discussed in the International Search Report.

It is thus respectfully submitted that the present PCT application now defines a novel invention involving an inventive step as well as having industrial applicability so as to thereby be patentable. An indication to that effect upon the Preliminary Examination to be conducted in the future is thus respectfully solicited.

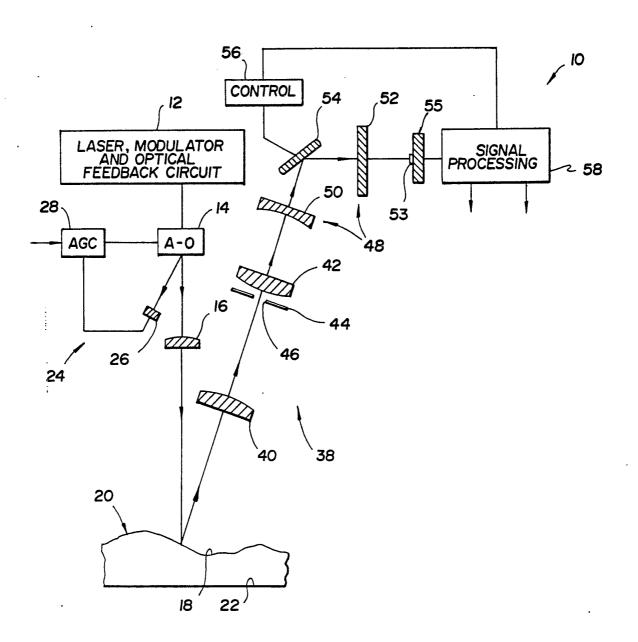
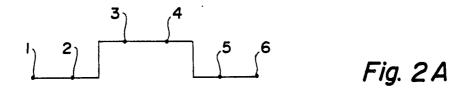
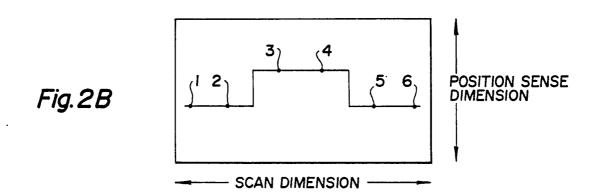
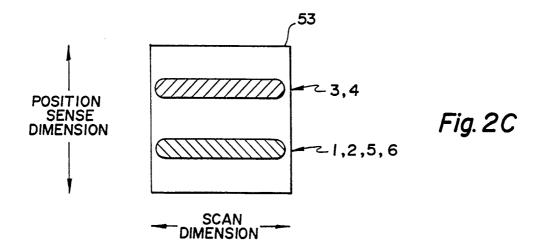


Fig. 1







INTERNATIONAL SEARCH REPORT

International Application No

PCT/US 88/04035

I. CLASSIFICATION OF SUBJECT MATTER (if several classification symbols apply, indicate all) 6											
	g to International Patent Classification (IPC) or to both N G 01 B 11/00, G 02 B 27/22	ational Classification and IPC									
II. FIELDS SEARCHED											
	Minimum Docum	entation Searched 7	document published after the international filing date for the date of the considered not be considered to the considere								
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IPC4	G 01 B; G 01 C; G 02 B										
Documentation Searched other than Minimum Documentation to the Extent that such Documents are Included in the Fields Searched *											
III. DOC	JMENTS CONSIDERED TO BE RELEVANTS										
Category *	Citation of Document, 11 with Indication, where ap	propriate, of the relevant passages 12	Relevant to Claim No. 13								
A	EP, A2, 0247833 (SYNTHETIC VIS 2 December 1987, see the whole document	ION SYSTEMS, INC.)									
A	US, A, 4355904 (BALASUBRAMANIAN 26 October 1982, cited in the applicati	•									
"A" doctoons "E" earli filing "L" doctoons "O" doctoons "P" doctoons IV. CERTI	I categories of cited documents: 10 Imment defining the general state of the art which is not sidered to be of particular relevance or document but published on or after the international grate ument which may throw doubts on priority claim(s) or the is cited to establish the publication date of another ion or other special reason (as specified) Imment referring to an oral disclosure, use, exhibition or or means Imment published prior to the international filing date but than the priority date claimed FICATION Actual Completion of the international Search Ebruary 1989	"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other auch documents, such combination being obvious to a person skilled in the art. "4" document member of the same patent family Date of Mailing of this international Search Report 3, 3, 89									
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ANNEX TO THE INTERNATIONAL SEARCH REPORT ON INTERNATIONAL PATENT APPLICATION NO.

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This annex lists the patent family members relating to the patent documents cited in the above-mentioned international search report. The members are as contained in the European Patent Office EDP file on 12/01/89. The European Patent Office is in no way liable for these particulars which are merely given for the purpose of information.

Patent cited in s	document earch report	Publication date	Pater meñ	t family hher(s)	Publication date
EP-A2- 024	7833	02/12/87	JP-A- GB-A-	63061110 2204947	17/03/88 23/11/88
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